



STW

PATENT
8020-1021-1

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of:

Yoshihisa MATSUBARA

Confirmation No. 7618

Serial No. 10/624,596

GROUP 2814

Filed July 23, 2003

Examiner Ginette Peralta

SEMICONDUCTOR DEVICE AND MANUFACTURING
METHOD OF THE SAME

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 17, 2004

Sir:

In response to the Official Action of June 17, 2004,
please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing
of claims that begins on page 2 of this paper.

Remarks begin on page 4 of this paper.